OVER SHEET 01-16-2003 IBM Docket No.: FIS920020154US1 the attached original documents or copy thereof. To the Honorable Commissioner me and address of receiving party(ies): 1. Name of conveying party 102339976 ANDREAS KNORR Name: Infineon Technologies North America Corp. Street Address: 1730 North First Street State: California Additional name(s) of conveying party(ies) attached? City: San Jose [X] No []Yes Zip Code: **95112** 3. Nature of Conveyance: Assignment Merger [X] [] Security Agreement [] Change of Name Additional Name(s) & Address(es) attached? [] Other _____ []Yes [X] No Execution Date: 12-19-02 Application number(s) or patent number(s): HIGH DENSITY PLASMA OXIDATION Title of Application: If this document is being filed together with a new application, the execution date of the application is: 12-19-02 , 19 . Patent Application No.(s) B. Patent No.(s) A. Additional numbers attached? [] Yes [X] No Name and address of party whom correspond-5. ence concerning document should be mailed: 6. Total number of applications and patents involved:..... 1] Name: Elsa Keller Street Address: Infineon Technologies North America Corp. Intellectual Property Law Department 186 Wood Avenue South 7. Total Fee (37 CFR 3.41) \$40.00 Iselin State: NJ Zip: **08830** Enclosed City: [] Authorized to be charged to Deposit [X] Account number below **CERTIFICATION OF MAILING UNDER 37 CFR 1.10** Any deficiencies in the enclosed fees [X] 'Express Mail" mailing label number EU702259605US Date of Deposit: 1-07-03 I hereby certify that this paper or fee is being deposited with the United States Postal Service Assignee IBM Corporation Deposit Account "Express Mail Post Office to Addressee" service under 37 CFR 1.10 Number: on the date indicated above and is addressed to the Commissioner for Patents and Trademarks, Washington, D.C. 20231 **09-0458** FI-015 Name: Karen Cing-Mars

Signature: Karense 01/15/2003 TDIAZ1 00000151 090458

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9. Statement and Signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Todd M. C. Li Name of Person Signing

odd M. C. Li Date: Jan. 7,2003

Registration No. 45,554

Phone No.: 845-894-6919 Total number of pages including cover sheet, attachments, and document: [3]

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ASSIGNMENT

For good and valuable consideration, I Andreas Knorr residing at 2607 Trailside Dr., Austin, Texas 78704, a citizen of Germany.

Hereby sell, assign and transfer to Infineon Technologies North America Corp., a corporation organized and existing under the laws of the state of Delaware, having its principal place of business at 1730 North First Street, San Jose, California, 95112, hereinafter "Assignee", its successor, assigns and legal representatives, the entire right, title and interest in and for the United States and all foreign countries, in an to any an all improvements which are disclosed in the application for the United State Letters Patent, which has been executed by the undersigned on Dec. 19, 2002 and is entitled:

HIGH DENSITY PLASMA OXIDATION

and in and to said application and all divisional, continuing, substitute, renewal, reissue, and all other applications for Letters Patent which have been or shall be filed in the United States and all foreign countries on any of said improvements; and in and to all original and reissued patents which have been or shall be filed in the United States and all foreign countries on said improvements;

Agree that said Assignee may apply for and receive Letters Patent for said improvements in its own name; and that, when requested, without charge to but at the expense of said Assignee, its successors, assigns and legal representatives, to carry out in good faith the intent and purpose of this assignment, the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all said improvements; execute all rightful oaths, assignments, powers of attorney and other papers; communicate to said Assignee, its successors, assigns, and legal representatives, all facts known to the undersigned relating to said improvements and the history thereof; and generally do everything possible which said Assignee, its successors, assigns or legal representatives shall consider desirable for aiding in securing and maintaining proper patent protection for said improvements and for vesting title to said improvements and all applications for patents and all patents on said improvements in said Assignee, its successors, assigns and legal representatives; and

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TITLE: HIGH DENSITY PLASMA OXIDATION

ASSIGNMENT

Covenant with said Assignee, its successors, assigns and legal representatives that no assignment, grant, mortgage, license or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein express is possessed by the undersigned.

Andreas Knorr	12/19/02 Date
Witness YouFAN LIU	12/19/02
	Date
Witness ibm/100370000asgn1infineon	

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